

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITING PROCEDURE
EXAMINING GROUP 2826**

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To Examiner: Kevin Quinto

Total Pages Sent: 7

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Facsimile Number: 703-872-9306

Transmission Date: May 25, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cheng, *et al.*

Docket No.: TSM03-0698

Serial No: 10/786,643

Art Unit: 2826

Date Filed: February 25, 2004

Title: Method and Structure for CMOS Devices with Stress Relaxed by Ion Implantation of Carbon or Oxygen Containing Ions

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- Certification of Facsimile Transmission (1 page)
- Response to Final Office Action Under 37 C.F.R. § 1.116 (6 pages)

Respectfully submitted,



Judy A. Betts
Legal Assistant

Confirmation Respectfully Requested

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Response To Final Office Action Under 37 C.F.R. § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to the Examiner's Final Office Action dated March 25, 2004. They are believed to be a full and complete response to said Action and to place the application in a condition for allowance or to place the application in a better condition for appeal. Entry is respectfully requested.

TSM03-0698

Amendment

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